

<b>Form 1449 (Modified)</b>  <b>Information Disclosure Statement By Applicant</b>  (Use Several Sheets if Necessary)			Atty Docket No. <b>CALIP001D1/P041D</b>	Application No.: <b>Filed Herewith</b>
			Applicant: <b>WALTER et al.</b>	
			Filing Date <b>Herewith</b>	Group <b>Unassigned</b>

#### U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
mc	A	5,745,271	04/28/98	Ford et al.	359	130	07/31/96
mc	B	6,222,954 B1	04/24/01	Riza	385	18	09/17/99
C							
D							
E							
F							
G							
H							
I							

#### Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
J								
K								
L								
M								
N								

#### Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
mc	O	Hiroshi Toshiyoshi and Hiroyuki Fujita, "Electrostatic Micro Torsion Mirrors for an Optical Switch Matrix", 1996 IEEE, Journal of Microelectromechanical Systems, Vol. 5, No. 4, pg. 231-7
	P	
	Q	

Examiner \_\_\_\_\_ Date Considered \_\_\_\_\_  
Michelle R. Connelly-Cushwa 12/9/04

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.